

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kramadhathi V. Ravi

Application No. 10/824,051

Filed: 04/13/2004

For: THIN SILICON CIRCUITS AND METHOD FOR  
MAKING THE SAME

Examiner: Nguyen, Joseph H.

Art Unit 2815

Confirmation No. 6109

PRELIMINARY AMENDMENT

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In connection with the filing of a Request for Continued Examination under 37 CFR §1.114, Applicant respectfully requests entry of the following amendments.